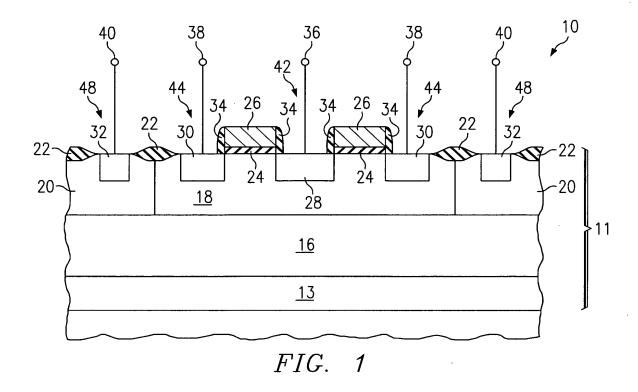


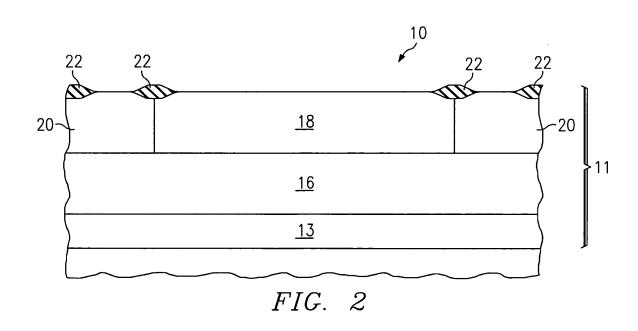
Method for Manufacturing and Structure of Semiconductor Device with Polysilicon Definition Structure

Attorney Docket: TI-33005 (032350.B372)

Inventor: Xiaoju Wu Filed: 11/29/01 Sheets 1 of 3

1/3

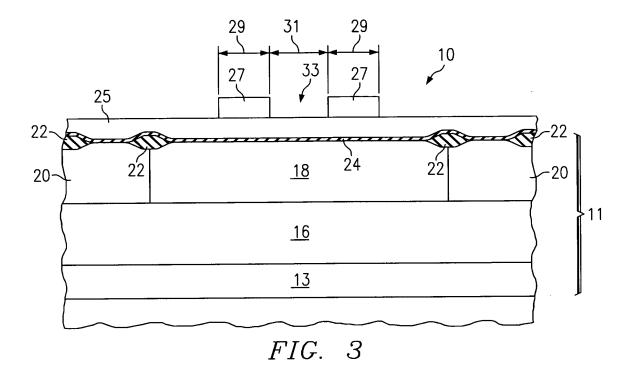


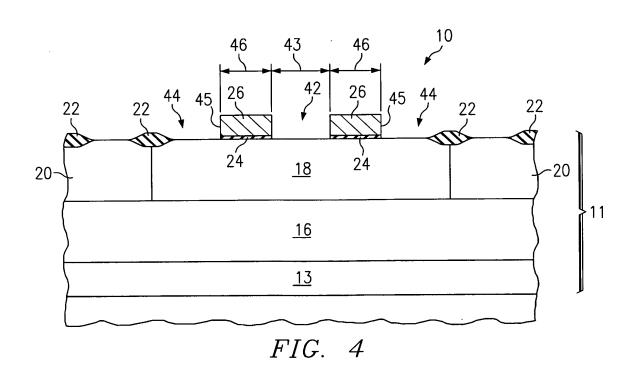


Method for Manufacturing and Structure of Semiconductor Device with Polysilicon Definition Structure

Definition Structure
Attorney Docket: TI-33005 (032350.B372)
Inventor: Xiaoju Wu
Filed: 11/29/01 Sheets 2 of 3

2/3





ethod for Manufacturing and Structure of Semiconductor Device with Polysilicon Definition Structure

Attorney Docket: TI-33005 (032350.B372)
Inventor: Xiaoju Wu
Filed: 11/29/01 Sheets 3 of 3

3/3

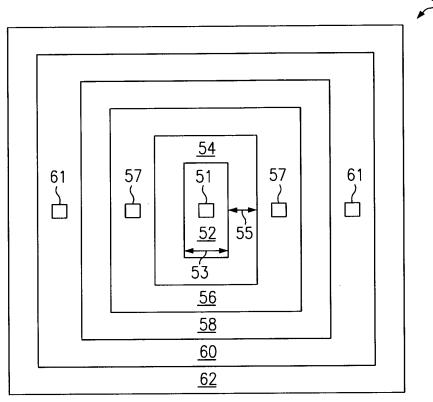


FIG. 5

